

All-optically induced quasi phase matching in SiN waveguides for second harmonic generation enhancement

Davide Grassani¹, Adrien Billat¹, Martin H. P. Pfeiffer², Svyatoslav Kharitonov¹, Tobias J. Kippenberg², Camille-Sophie Brès^{1*}

¹Ecole Polytechnique Fédérale de Lausanne (EPFL), Photonic Systems Laboratory, CH-1015, Switzerland

²Ecole Polytechnique Fédérale de Lausanne (EPFL), Laboratory of Photonics and Quantum Measurements, CH-1015, Switzerland

Author e-mail address: camille.bres@epfl.ch

Abstract: We report more than 30dB second harmonic generation enhancement in SiN waveguide by all-optical writing of a persistent $\chi^{(2)}$ grating. Phase matching peaks are observed for different writing wavelengths.

OCIS codes: (190.4390) Nonlinear optics, integrated optics; (190.2620) Harmonic generation and mixing.

1. Introduction

Thanks to tight light confinement and fabrication flexibility, CMOS compatible materials like silicon (Si) and silicon nitride (SiN) allowed the integration of various $\chi^{(3)}$ -based optical functionalities on chip [1][2]. Integration of $\chi^{(2)}$ -based effects would enable even more efficient devices and new compelling applications like on-chip detection of telecom signal with integrated silicon detectors [3], photon pair generation with easier pump filtering [4], and self-referencing of frequency comb [5]. Unfortunately, $\chi^{(2)}$ theoretically vanishes in the dipole approximation both for Si and SiN. On the one hand, attempts were reported to integrate well performing $\chi^{(2)}$ materials, such as lithium niobate [6], on CMOS waveguides. On the other hand, photonic confinement leading to resonant structures with limited bandwidth [7], or symmetry breaking in strained Si waveguides [8] were employed to enhance the efficiency of second order processes. SiN, in particular, is a very promising material as it features a very large transparency window (from visible to mid-infrared), and already exhibited interesting bulk second order nonlinearity [9]. However, the conversion efficiency is often limited by the modal phase matching condition, which imposes stringent constraint on the waveguide design. Here we show the enhancement by more than 30 dB of the second harmonic of a narrow linewidth telecom pulsed laser. We observe a similar SHG enhancement changing the pump laser wavelength within the erbium window. Finally, probing the waveguide in continuous-wave (CW), the SHG peak shifts accordingly to the employed pump wavelength. We report a maximum SHG efficiency of $1.23 \cdot 10^{-6} \text{ W}^{-1} \text{ cm}^{-1}$ and we estimate $\chi^{(2)}$ to be about 0.3 pm/V .

2. Results and discussion

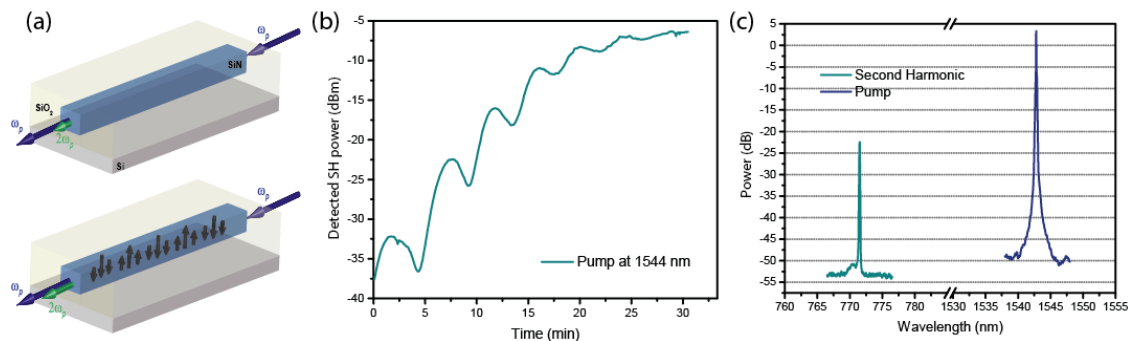


Fig. 1: (a) Schematic principle of $\chi^{(2)}$ grating inscription in SiN waveguides, where ω_p is the pump frequency. (b) SH power growth over time, during the grating inscription, when 90 W peak power at 1544 nm are coupled into the waveguide (c) Pump and harmonic spectra obtained after growth, for a coupled pump peak power of 90 W.

The waveguide is made of stoichiometric SiN buried in SiO₂ (see Fig. 1(a)) and is fabricated according to the photonic Damascene process [10], featuring low attenuation (0.2 dB/cm). It is 4 cm long with a cross section of $0.87 \times 1.5 \mu\text{m}$ and terminated by inverse taper mode converters. The pump consists of a modulated tunable C-band laser, amplified by a cascade of erbium-doped fiber amplifiers. The resulting pulses are 200 ps long, at a repetition rate of 25 MHz. At the output facet, short and long pass filters are used to remove the remaining pump and third-harmonic green light, before sending the output to a Si power detector. Fig. 1(b) shows the signal collected on the detector, found to be TM polarized, when a pump peak power of 90 W at 1544 nm pump is coupled into the

waveguide on the TM fundamental mode. The initially weak SH grows by 30 dB over several tens of minutes, while the coupled pump power remains constant, to reach a conversion level of $1.23 \cdot 10^{-6} \text{ W} \cdot \text{cm}^{-1}$. Fig. 1(c) features a spectrum showing the pump and corresponding second harmonic signals. Subsequently, we probe the waveguide with a CW laser, swept over the C-band. We observe a SH power peak centered at the pumping wavelength. Changing the pump wavelength, we observe a similar enhancement to that reported in Fig. 1(b), while the SHG peak wavelength changes accordingly when probing the waveguide in CW. These probing results are shown in Fig. 2(a),

The SHG enhancement, with a clear phase matching peak at the pump wavelength, has been observed in silica fibers pumped by a kW-level pulsed Nd:YAG laser [11]. The effect is attributed to a periodic modification of the material $\chi^{(2)}$ that progressively builds up during the illumination due to a coherent photogalvanic effect caused by the pump and SH waves [12]. The period of the resulting $\chi^{(2)}$ grating is twice the coherence length between the pump and SH waves, allowing for quasi phase matched SHG at the pump frequency. From finite element method simulations, we retrieve the waveguide dispersion curves for the pump and SH modes (Fig. 2(b)). We see that a weak and poorly phase matched SHG is expected to take place initially on the 8th TM mode at our pump frequency. Thanks to the experimental parameters and to the simulated pump and second harmonic mode profiles, we retrieve a $\chi^{(2)}$ of 0.3 pm/V by fitting the data from Fig. 2(c). The latter plots the generated SH power as a function of coupled probe power, while the fitting model assumes quasi phase matching.

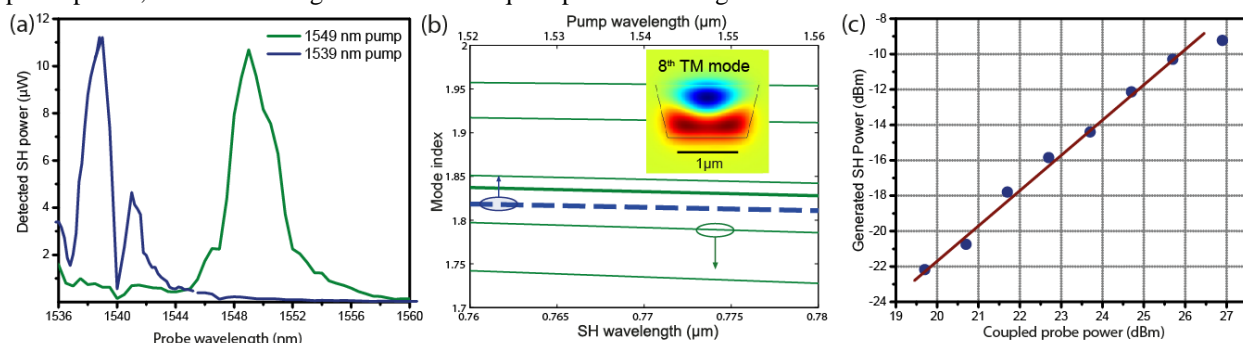


Fig. 2: (a) SH power as a function of the CW probe wavelength, in waveguides previously pumped at 1539 and 1549 nm. Phase-matching peaks are observed around each pump wavelength. (b) Index matching curves for the fundamental TM mode at the pump wavelengths (blue dashed line), and for the higher order TM modes at the SH wavelengths (green lines). The inset represents the simulated second harmonic mode profile. (c) SH power (estimated in the waveguide) as a function of the coupled CW probe power, for a 1543 nm probe in a waveguide previously pumped at 1543 nm. Dots are experimental data while the red line is a guide for the eye representing the expected slope of 2 for SHG.

This result represents a straightforward way to increase SHG efficiency in a CMOS compatible material like SiN for arbitrary wavelengths in the telecom band. At quasi-phase matching, we report a SHG efficiency comparable to that reported in SiN resonant structures [7], with the benefit of a wider bandwidth. Even higher conversion efficiencies are expected using Si-rich SiN, which exhibits $\chi^{(2)}$ values ten times larger than the stoichiometric compound [13]. Phase matched SHG in SiN waveguides can then compete with conventional $\chi^{(2)}$ materials, but with fairly easier on-chip integration, and with the capability of dynamically and all-optically reconfigure the phase matching configuration.

This work was supported by the European Research Council under grant agreement ERC-2012-StG 306630-MATISSE, and by Contract HR0011-15-C-0055 from the Defense Advanced Research Projects Agency (DARPA), Defense Sciences Office (DSO).

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